OCT 1 4 2008

IFW AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 6129

Kaoru YAMADA et al.

Attorney Docket No. 2006 0044A

Serial No. 10/564,980

: Group Art Unit 3723

Filed January 18, 2006

Examiner Bryan R. Muller

SUBSTRATE PROCESSING APPARATUS, :

Mail Stop: AF

SUBSTRATE PROCESSING METHOD, AND

SUBSTRATE HOLDING APPARATUS

AMENDMENT AFTER FINAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated August 12, 2008, please amend the above-identified application as follows.